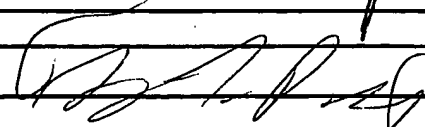


Substitute for Form 1449 A & B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>			Complete if Known	
			Application Number	Unknown
Sheet <u>1</u> of <u>1</u>			Confirmation Number	Unknown
			Filing Date	November 25, 2003
			First Named Inventor	Yasunori BITO
			Art Unit	Unknown
			Examiner Name	Unknown
			Attorney Docket Number	Q78644

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US			
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FOREIGN PATENT DOCUMENTS							
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
TD		Y. Bito et al., "64% Efficiency Enhancement-Mode Power Heterojunction Fet for 3.5 V Li-ION Battery Operated Personal Digital Cellular Phones", 1998 IEEE MTT-S Int. Microwave Symp-Dig., June 1998, pp. 439-442 with Abstract.	
TD		S. Wada et al., "0.1- μ m p ⁺ -GaAs Gate HJFET's Fabricated Using Two-Step Dry-Etching and Selective MOMBE Growth Techniques", IEEE Transactions on Electron Devices, Vol. 45, No. 6, June 1998, pp. 1383-1389 with Abstract.	
TD		K. Nishii et al., "High Current/gm Self-Aligned PJ-HFET of Completely Enhancement-Mode Operation", Extended Abstracts of the 1998 International Conference on Solid-State Devices and Materials, 1998, pp. 396-397.	

Examiner Signature		Date Considered	12/12/04
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